



Docket No.: 52433/797

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants : Tadashi ISHIKAWA et al.
Serial No. : 10/535,346
Conf. No. : 7148
Art Unit : 1793
Examiner : Mark L. Shevin
Filing Date : October 3, 2005
For: : METHOD OF PRODUCTION OF STEEL PRODUCT WITH
NANOCRYSTALLIZED SURFACE LAYER

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to: Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on **April 5, 2010**

Signature: Katy Chan-Parsons
Katy Chan-Parsons

AMENDMENT UNDER 37 C.F.R. § 1.116

S I R:

In response to the Office Action dated January 4, 2010, Applicants respectfully request entry of the following amendment and remarks into the file of the above-identified application.

Amendments to the Claims are reflected in the Listing of Claims which begins on page 2 of this paper.

Remarks begin on page 5 of this paper.